



520.35237VX3

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: T. KAJI, et al.  
Application No.: 10/052,538  
Filed: January 23, 2002  
For: PLASMA PROCESSING APPARATUS PROCESSING  
METHOD  
Art Unit: 1763  
Examiner: A. M. Crowell

**AMENDMENT AND STATEMENT OF SUMMARY OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 25, 2005

Sir:

In response to the Office Action dated September 21, 2004, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and set forth on the following pages:

**Amendments to the Claims and**

**Remarks are included following the amendments.**